

MAR-17-03

06:23PM

FROM- MATTINGLY, STANGER & MALUR, P.C.

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T-080 P.004/018 F-151

NIT-215

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

S. KONDO et al

Serial No. 09/637,570

Group Art Unit: 2812

Filed: August 14, 2000

Examiner: Ha T. Nguyen

For: POLISHING METHOD, METALLIZATION FABRICATION
METHOD, METHOD FOR MANUFACTURING SEMICONDUCTOR
DEVICE AND SEMICONDUCTOR DEVICE

#15 Amend 3
Ref 2
Amend
3/29/03
JW
4/21/03

AMENDMENT

Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Office Action dated November 15,
2002, please amend the above-identified application as
follows.

FAX RECEIVED

MAR 17 REC'D

TECHNOLOGY CENTER 2800